

1/25

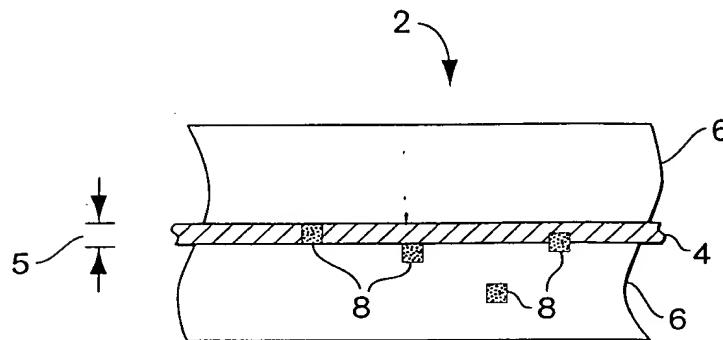


Fig. 1

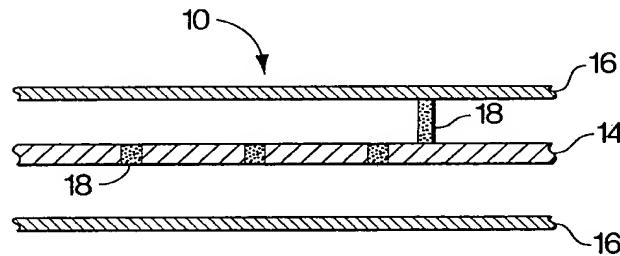


Fig. 2A

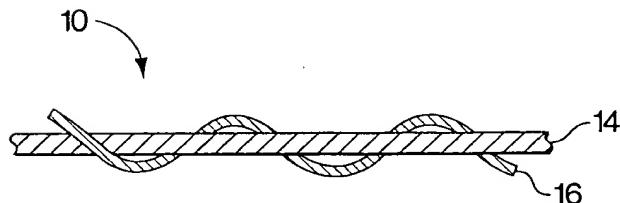


Fig. 2B

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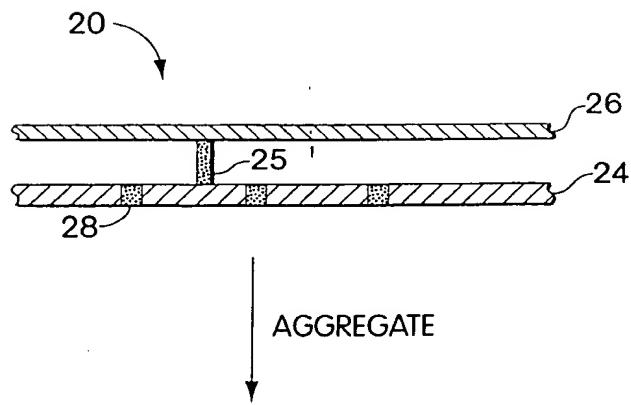


Fig. 3A

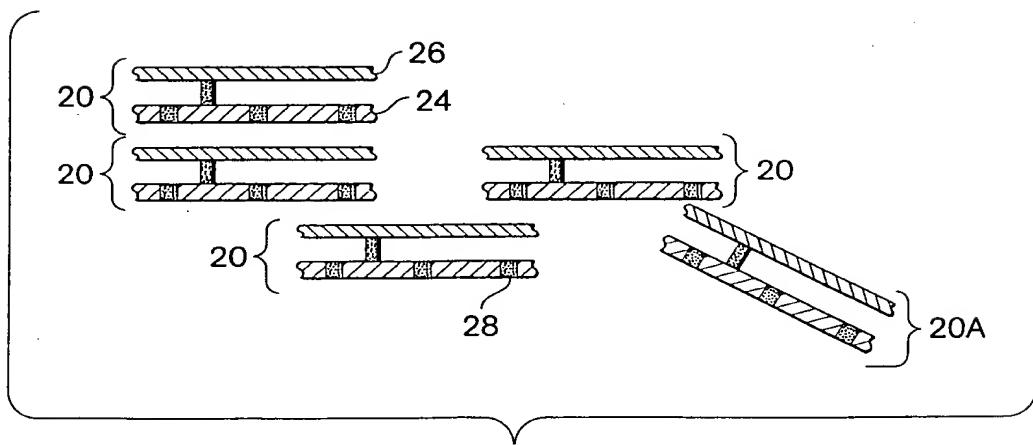


Fig. 3B

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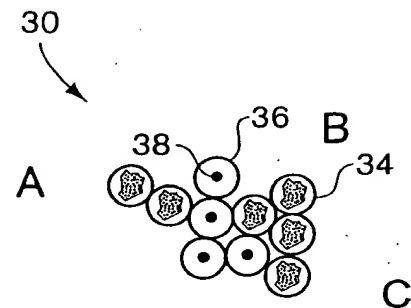


Fig. 4A

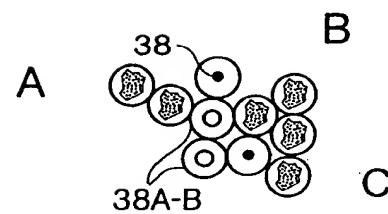
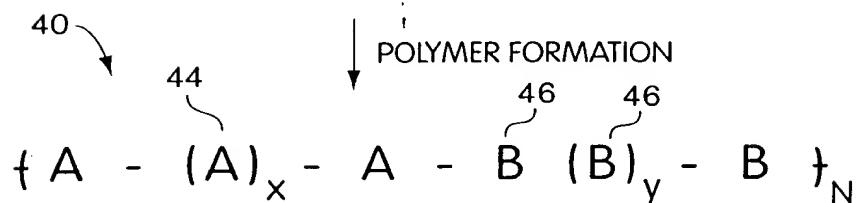
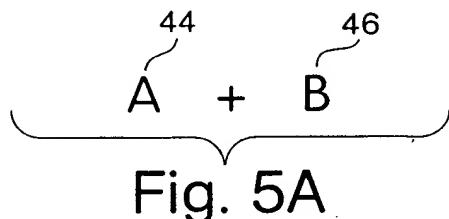


Fig. 4B

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N = 1 or more than 1

Fig. 5B

50 → 54 56 ↓ FILM FORMATION /
MICROPHASE SEPARATION

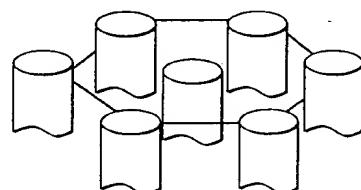
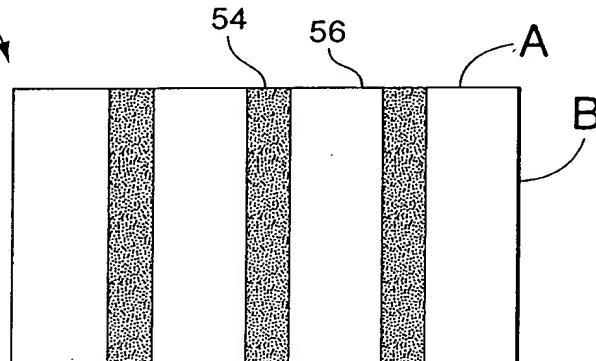


Fig. 5C

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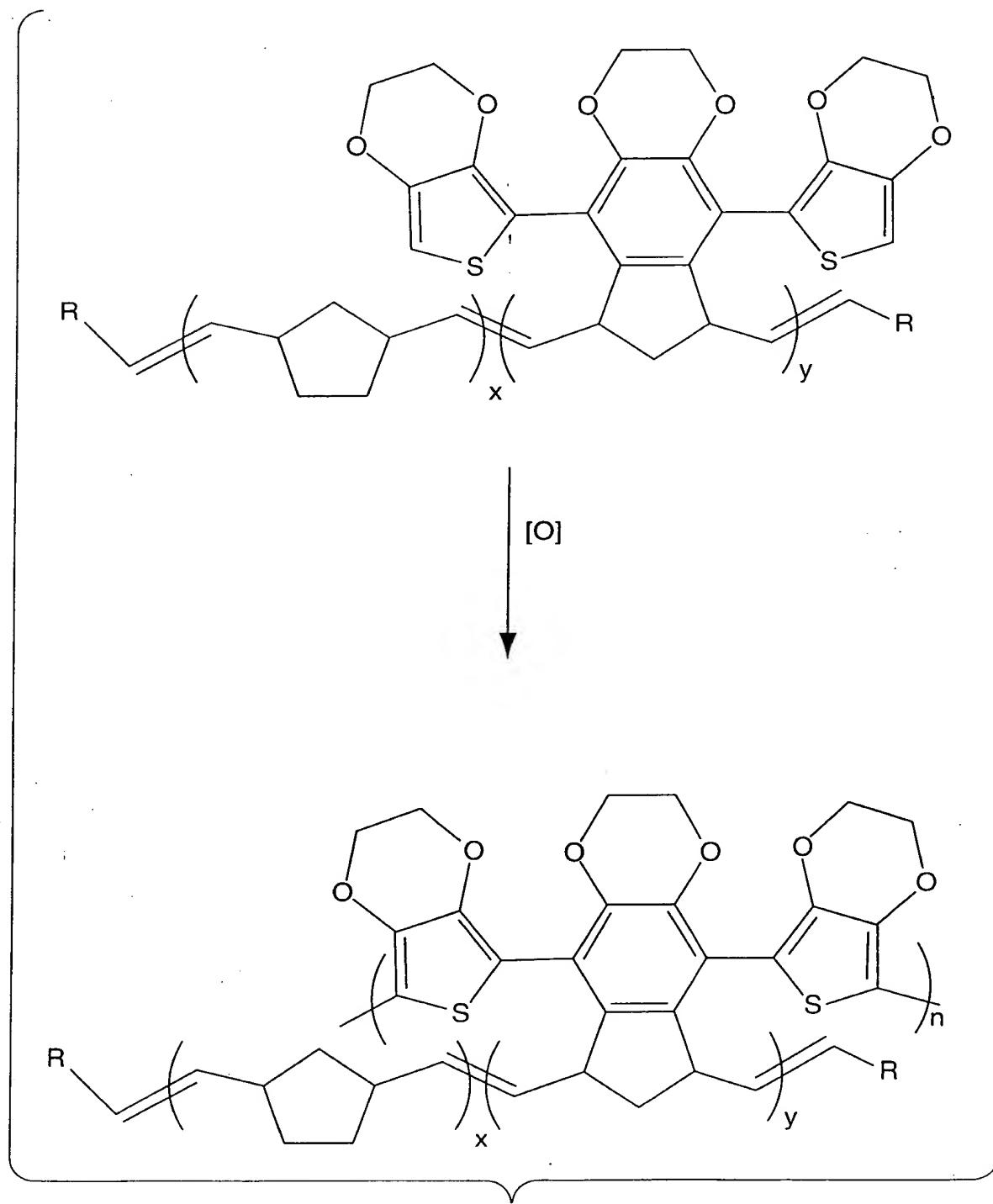


Fig. 6A

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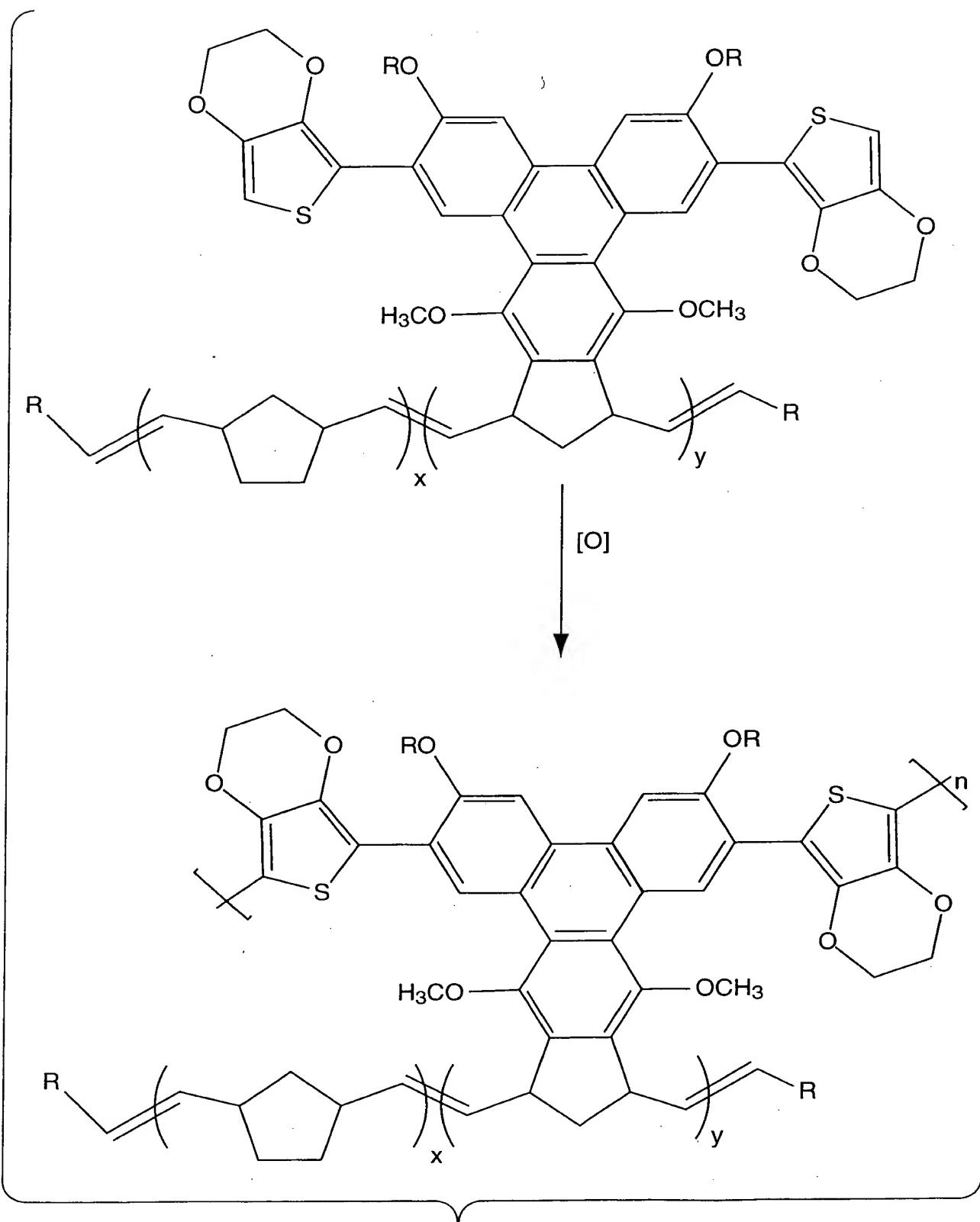


Fig. 6B

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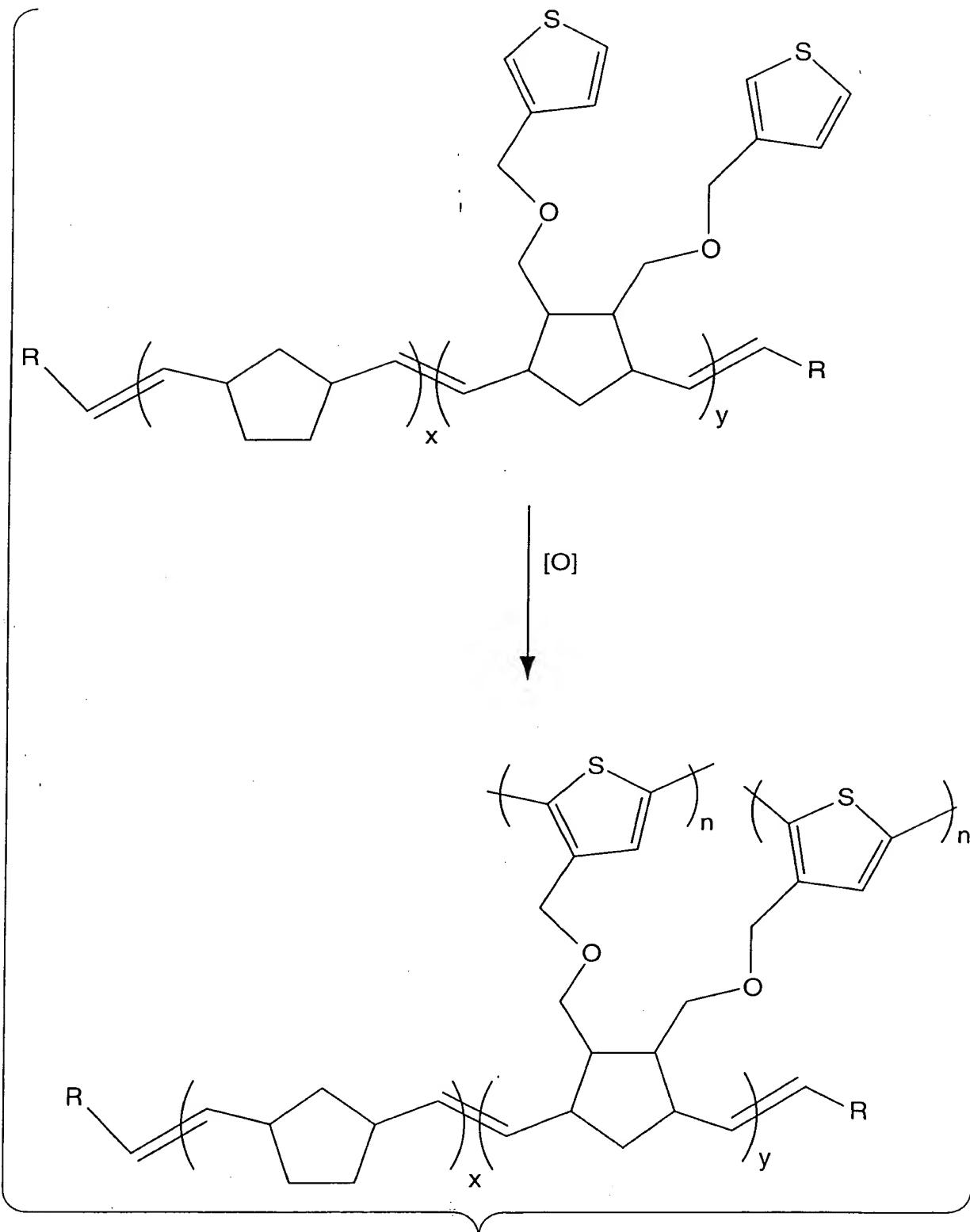


Fig. 7

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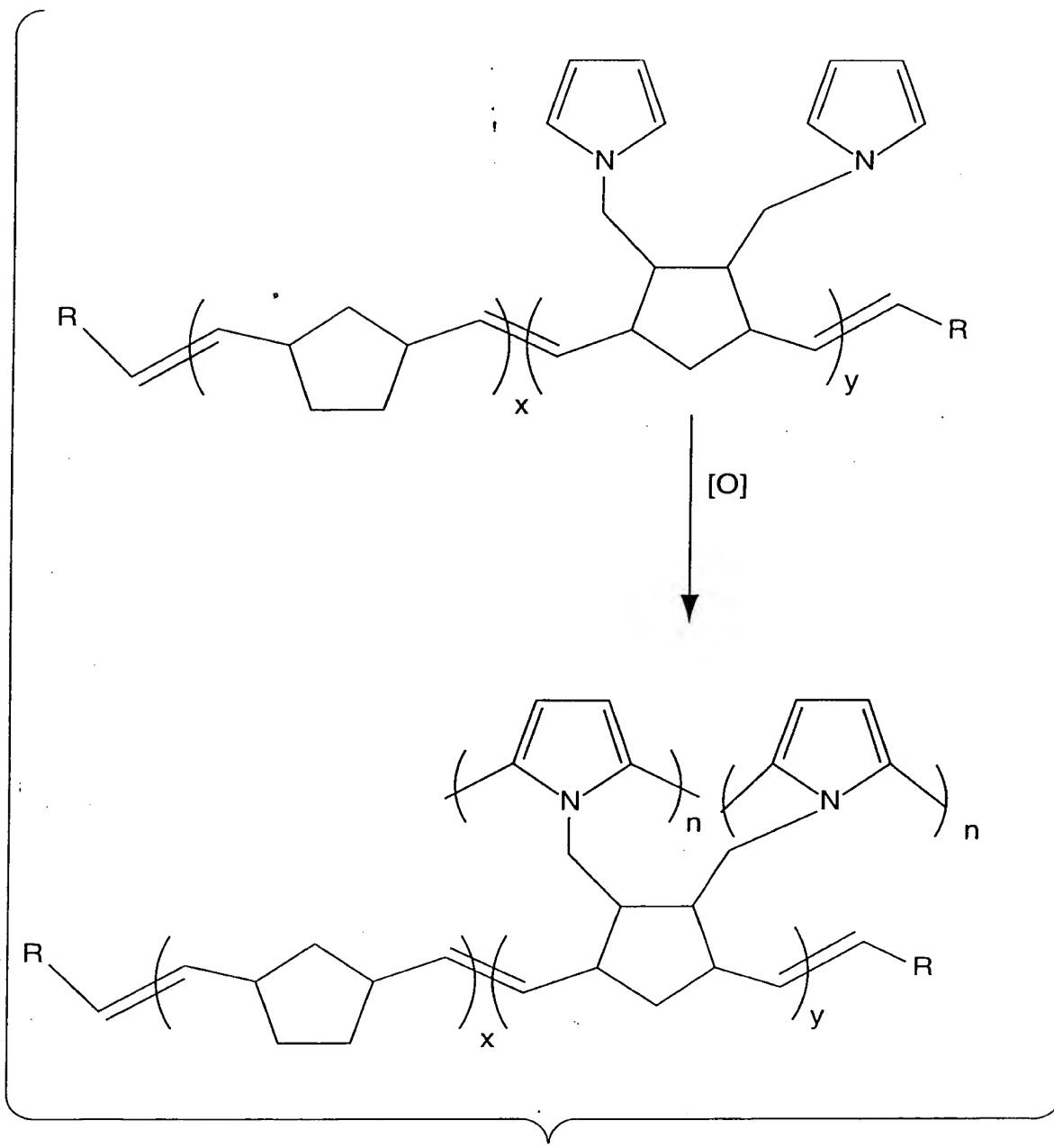


Fig. 8

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BLOCK POLYMERS TO BIND METAL OR SEMICONDUCTOR NANOPARTICLES

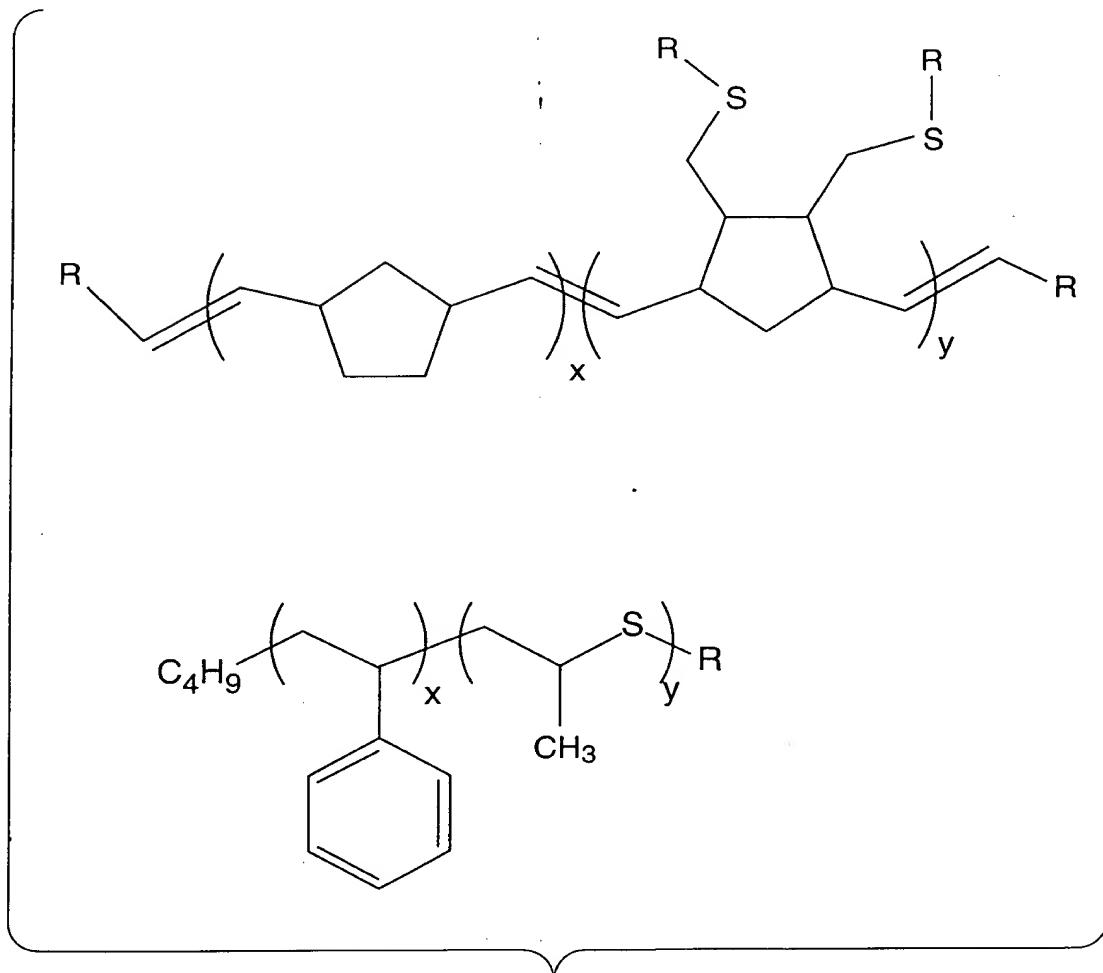


Fig. 9

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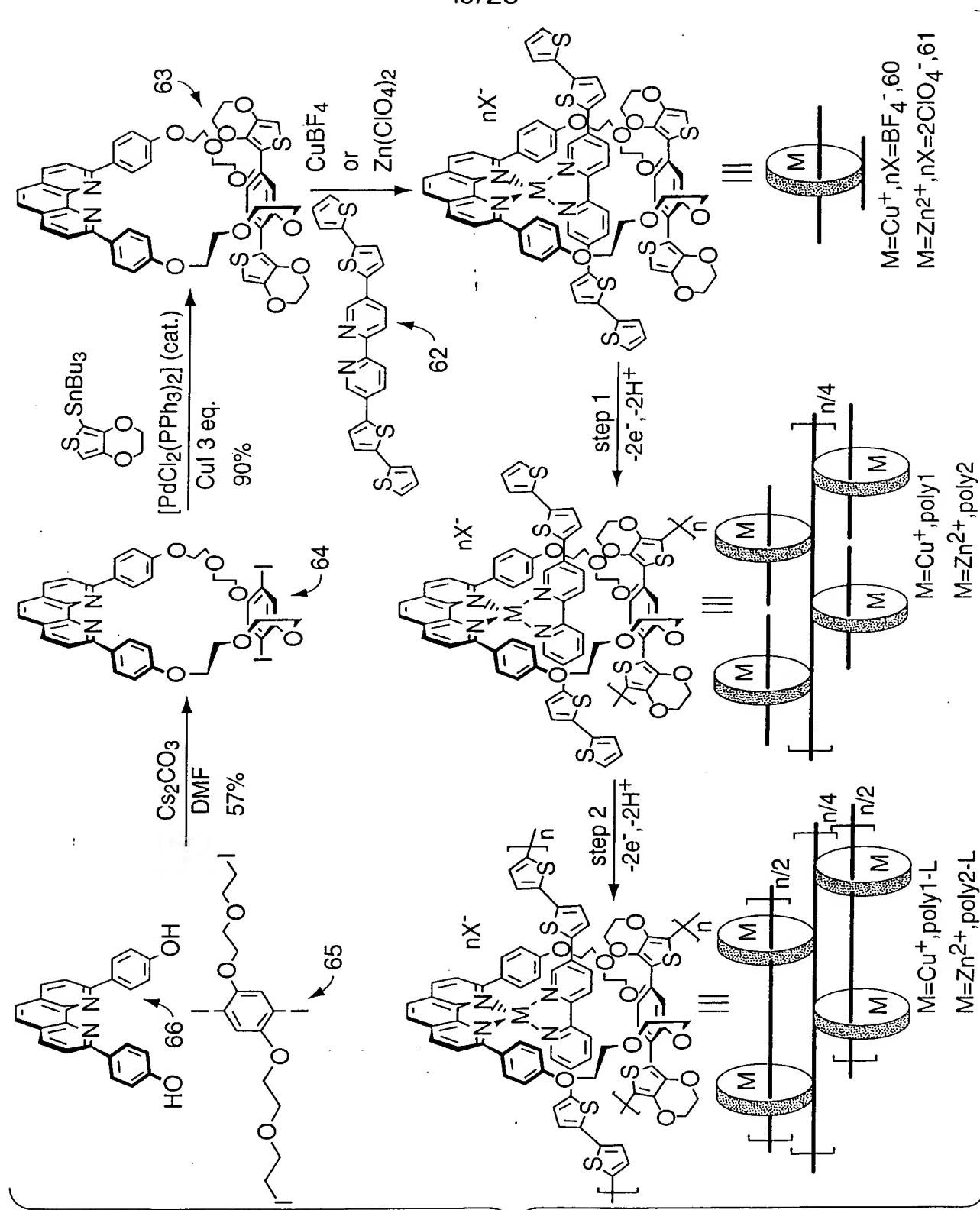


Fig. 10

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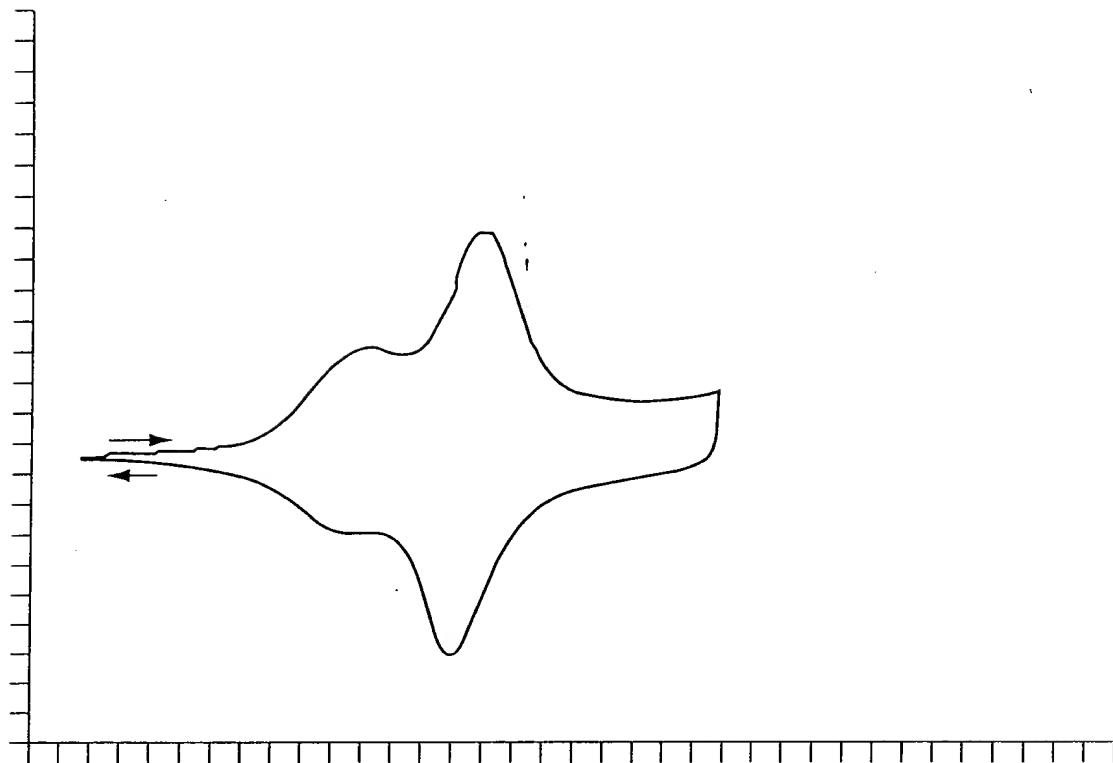


Fig. 11A

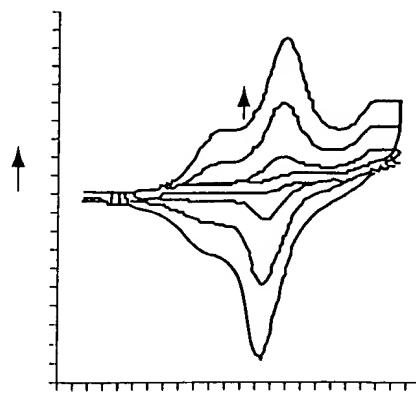


Fig. 11B

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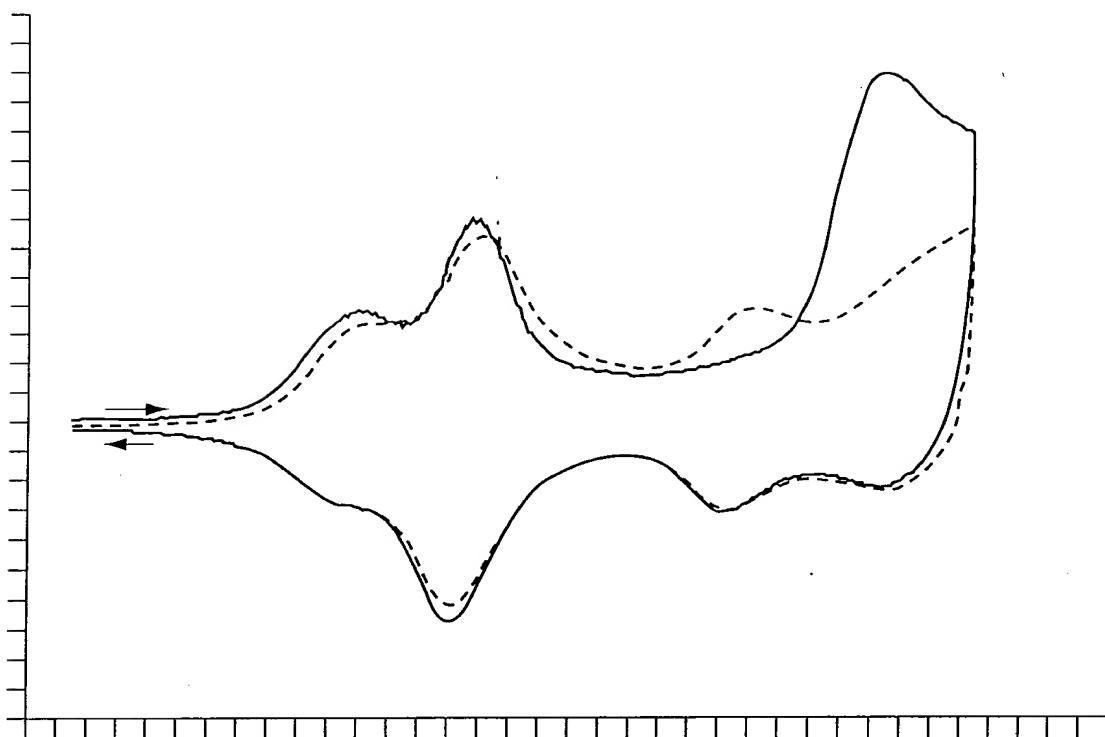


Fig. 11C

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Fig. 12A

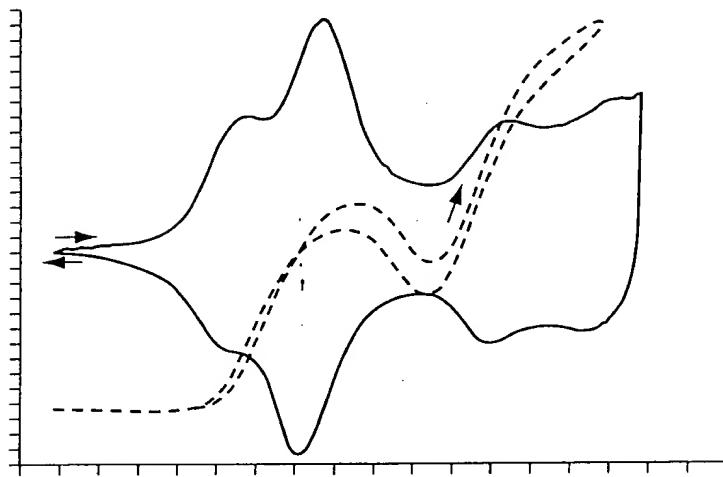


Fig. 12B

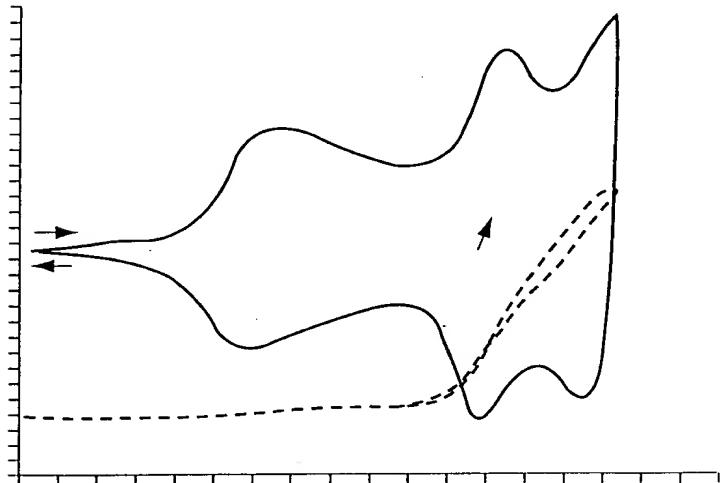
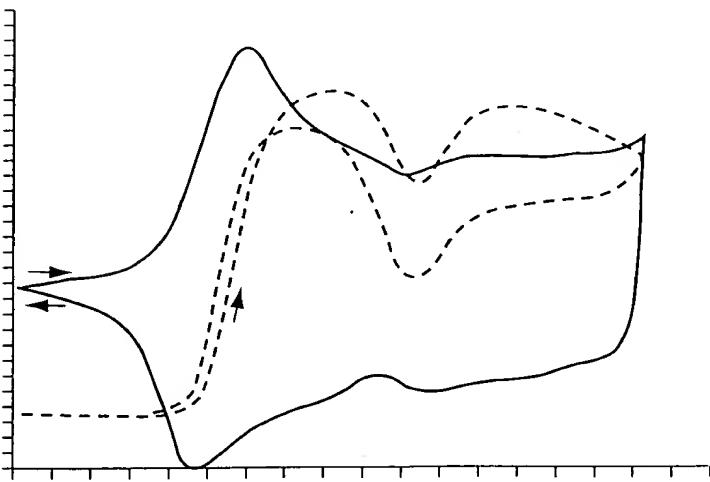


Fig. 12C



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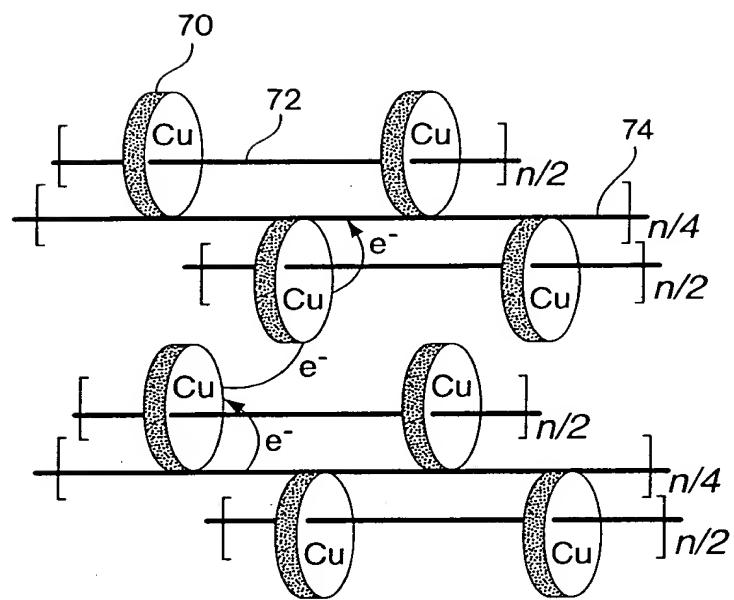
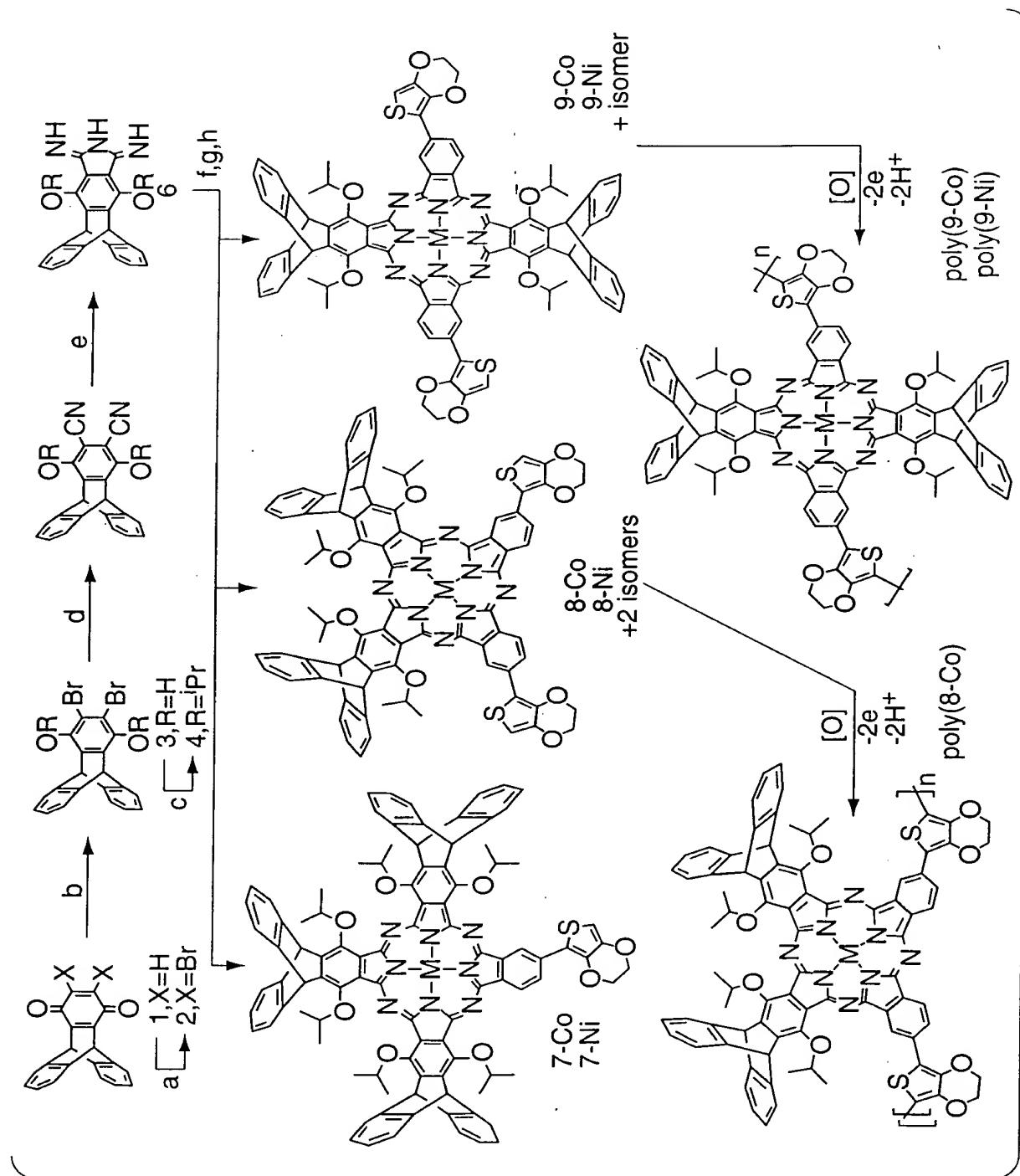


Fig. 13

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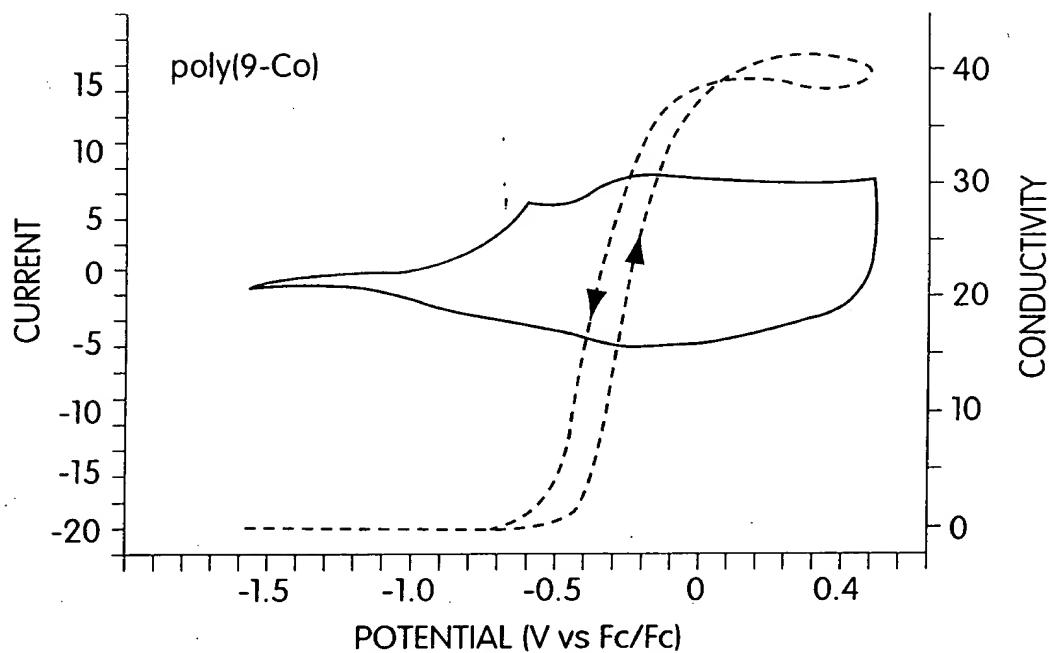


Fig. 15A

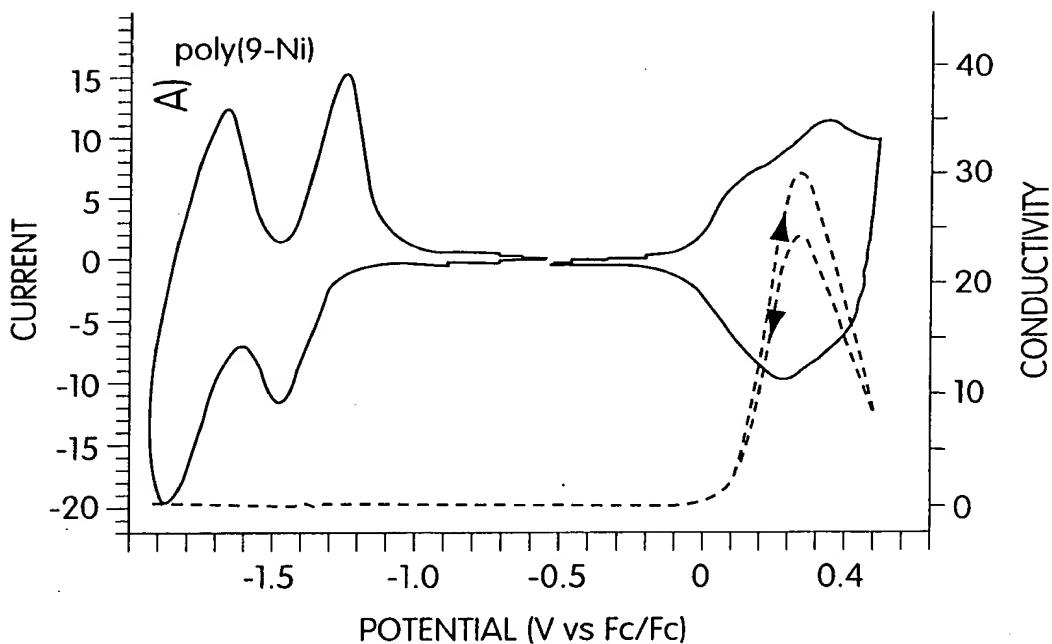


Fig. 15B

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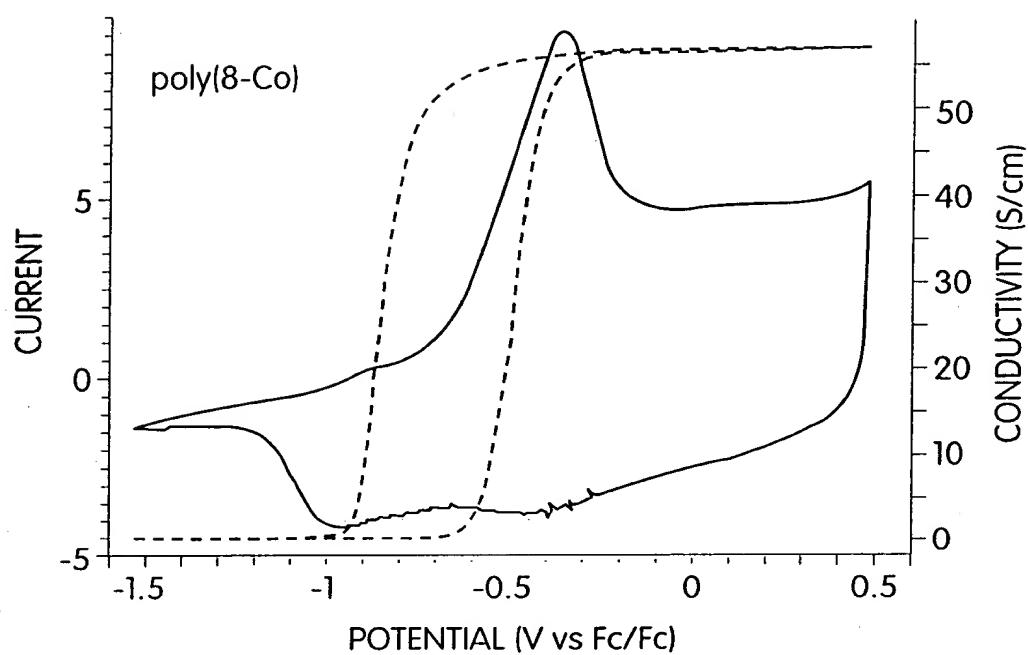


Fig. 16

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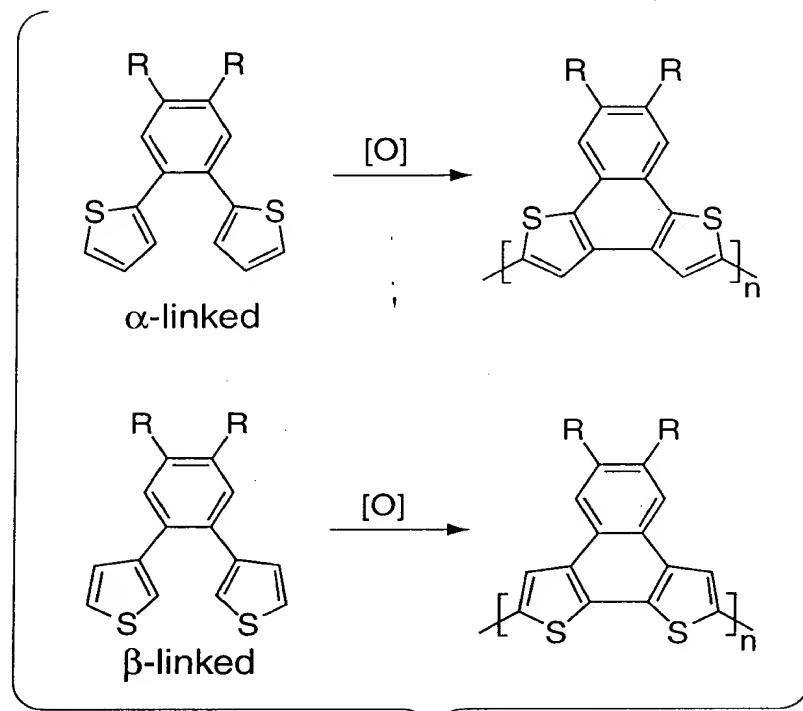


Fig. 17

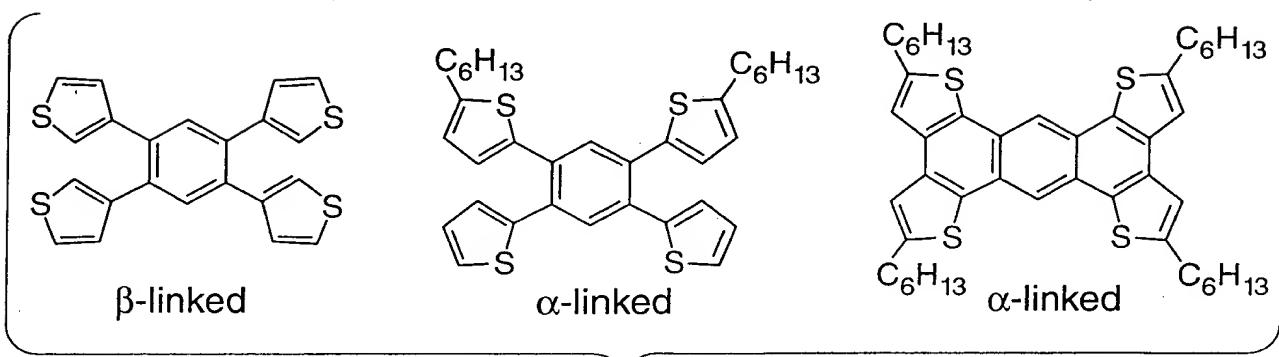


Fig. 19

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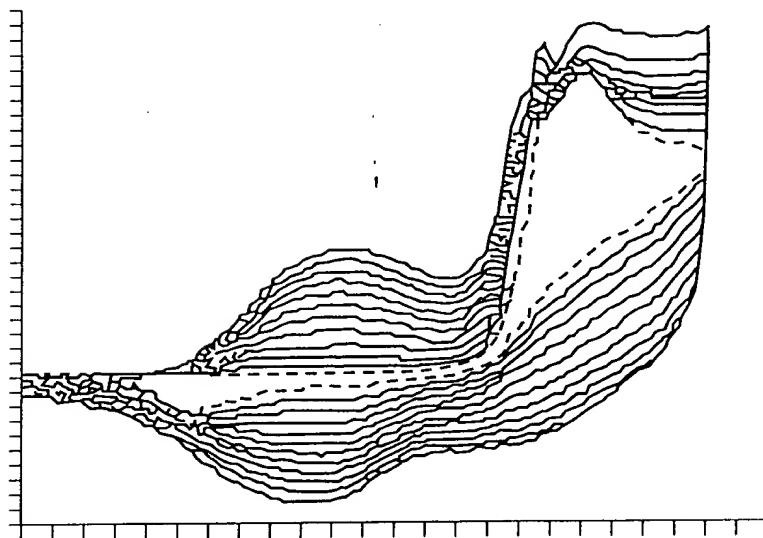


Fig. 18A

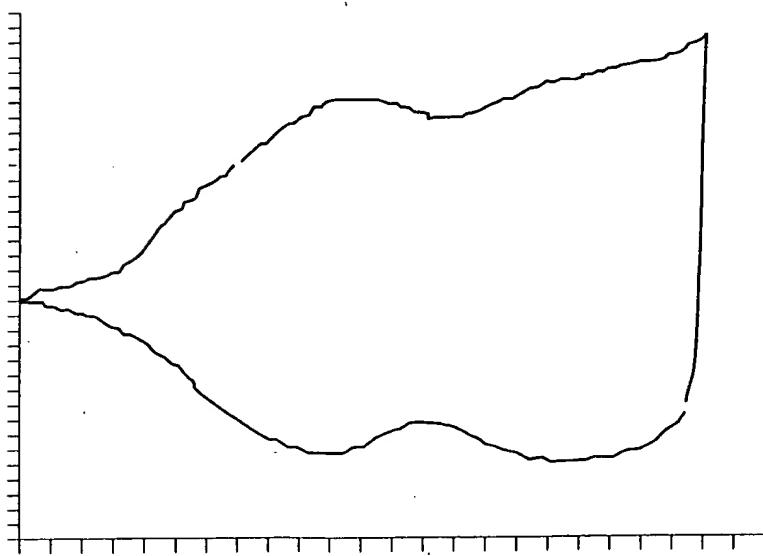


Fig. 18B

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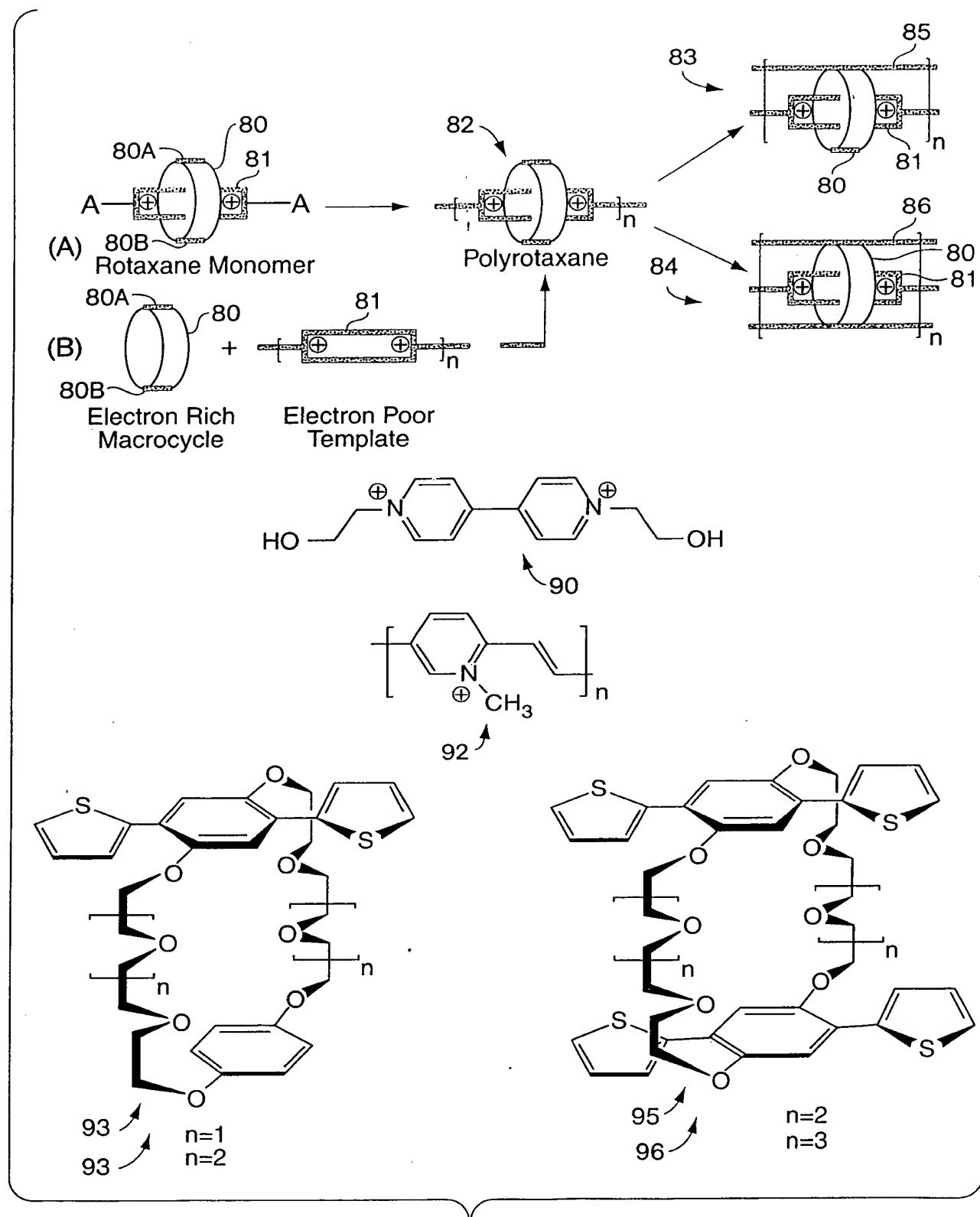


Fig. 20

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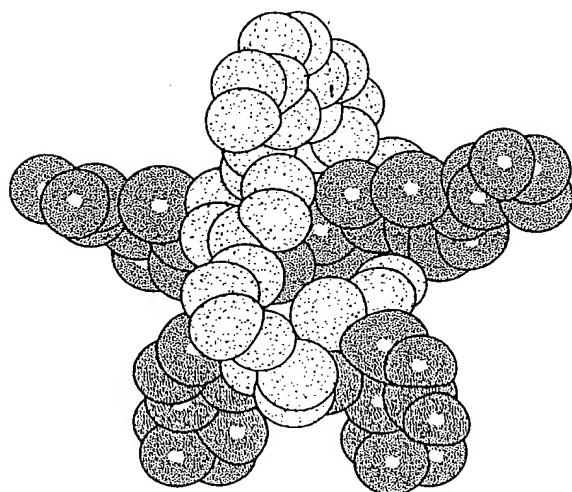


Fig. 21A

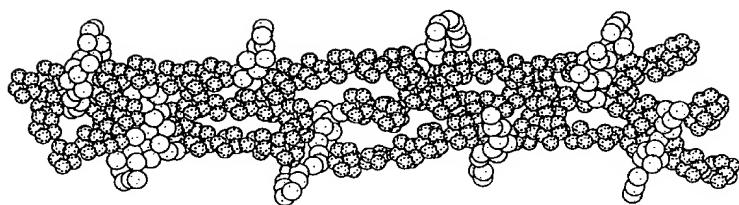


Fig. 21B

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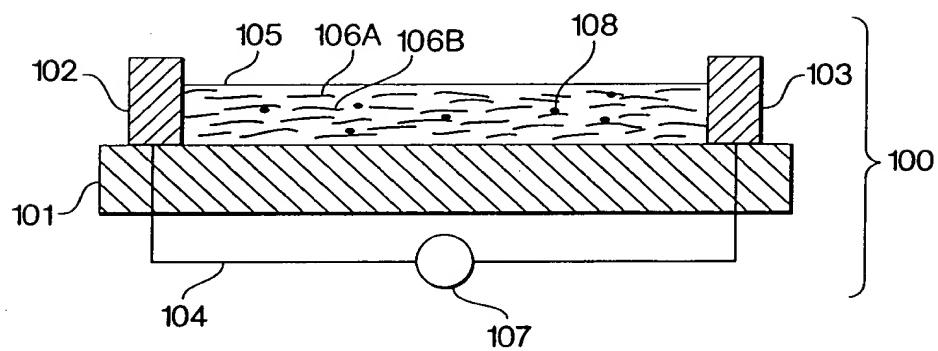


Fig. 22
(Prior Art)

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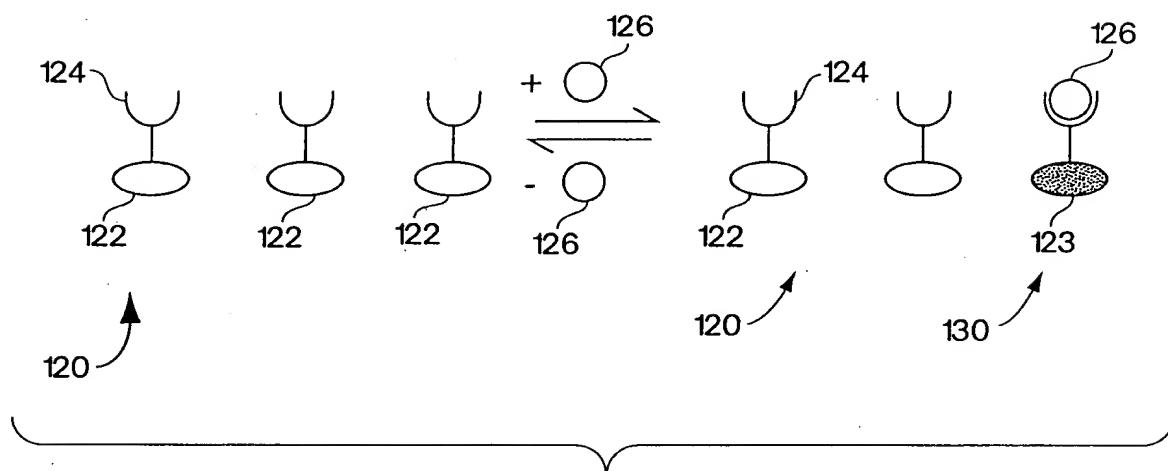


Fig. 23
(Prior Art)

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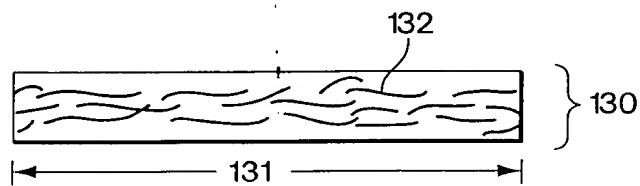


Fig. 24

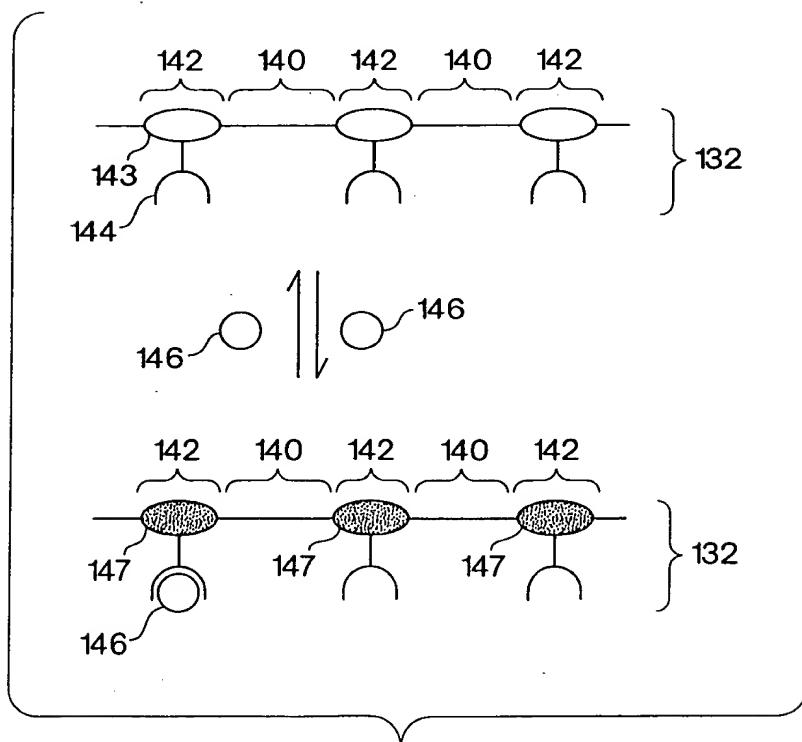


Fig. 25
(Prior Art)

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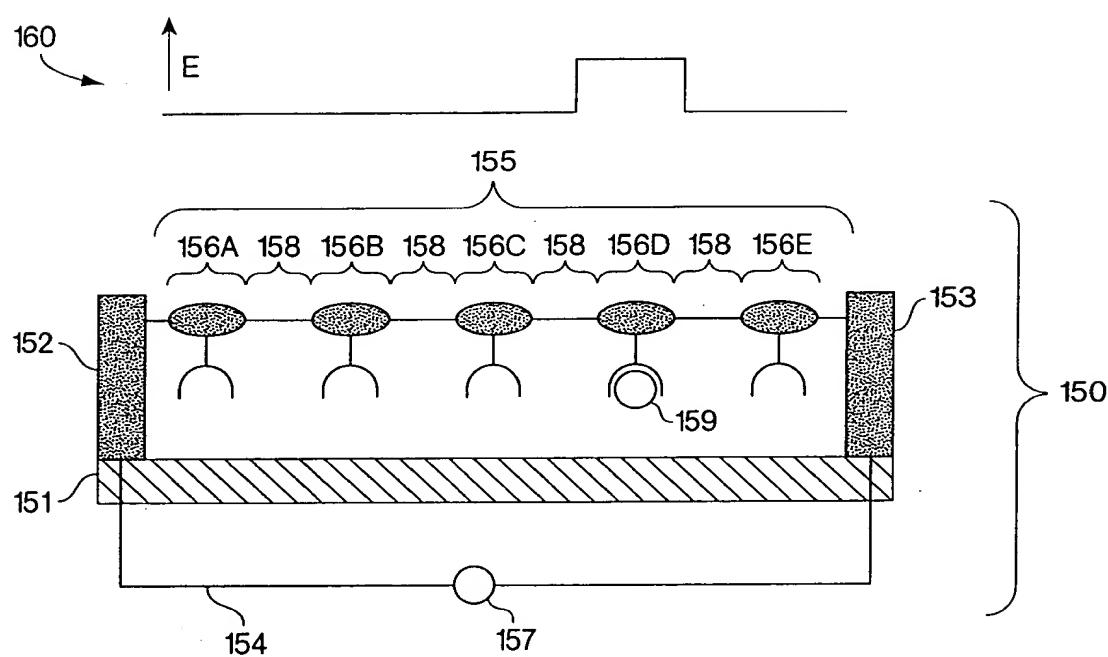


Fig. 26